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1765
AF
Serial No. 10/023,948
SEC.861
Amendment dated October 29, 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of :
Jae-dong Lee et al. : Group Art Unit 1765
Serial No. 10/023,948 : Examiner Lynette T. Umez-Eronini
Filed December 21, 2001 :
CHEMICAL MECHANICAL POLISHING SLURRY

AMENDMENT AFTER FINAL

U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, Mail Stop AF
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

In response to the Office Action of August 27, 2003, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.